



INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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First Named Inventor	Nishimura
Art Unit	2881
Examiner Name	not yet assigned

U.S. PATENT DOCUMENTS

NOTE: If this application was filed after June 30, 2003, copies of United States patents and United States published patent applications do not have to be provided to the Patent Office. This requirement of 37 C.F.R. § 1.98(a)(2)(i) has been waived by the United States Patent and Trademark Office pursuant to the Official Gazette Notice on August 5, 2003 (1276 OG 55).

Examiner's Initials*	Cite No. (optional)	Number	Publication Date	Name of Applicant or Patentee
<i>[Signature]</i>	<i>[Signature]</i>	6,107,636	22-Aug-2000	Muraki
<i>[Signature]</i>		6,365,897	2-Apr-2002	Hamashima et al.
<i>[Signature]</i>		6,593,152	15-Jul-2003	Nakasuji et al.
<i>[Signature]</i>		6,608,308	19-Aug-2003	Takagi et al.
<i>[Signature]</i>		6,653,631	25-Nov-2003	Nishimura
<i>[Signature]</i>		6,661,008	9-Dec-2003	Takagi et al.
<i>[Signature]</i>		6,717,145	6-Apr-2004	Takagi et al.
<i>[Signature]</i>		2002/0033449	21-Mar-2002	Nakasuji et al.
<i>[Signature]</i>		2003/0207475	6-Nov-2003	Nakasuji et al.
Examiner's Initials*	Cite No. (optional)	OTHER DOCUMENTS		
<i>[Signature]</i>		Tsuno, "Simulation of a Wien Filter as Beam Separator in a Low Energy Electron Microscope," <i>Ultramicroscopy</i> 55:127-140 (1994).		

EXAMINER SIGNATURE: <i>[Signature]</i>	DATE CONSIDERED: 7/23/05
<p>* Examiner: Initial if reference considered, whether or not in conformance with MPEP 609. Draw line through cite if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>	